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Supplementary Information

Pd₃Bi intermetallic particles prepared by photodeposition method for photocatalytic ethane production from methane

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S1. Experimental

S1.1 Materials

The following chemicals were used as received without further purification. Gallium oxide (Kojundo Chemicals, GA004PB, 99.99%), a Pd standard solution (Pd(NO₃)₂ in 6.6 mol L⁻¹ HNO₃ (aq.) containing 5 mg mL⁻¹ Pd, Wako Chemicals), a Bi standard solution (Bi(NO₃)₃ in 0.5 mol L⁻¹ HNO₃ (aq.) containing 1 g L⁻¹ Bi, Wako Chemicals), methanol (Wako Chemicals, 99.8%), Silica gel (CARiACT G-3, Fuji Silysia Chemical Ltd), 5,5-dimethyl-1-pyrroline *N*-oxide (DMPO).

CH₄ (Taiyo Nippon Sanso, 99.999% pure) was used as a reactant. Ar (Taiyo Nippon Sanso, 99.9975% pure) and He (Japan Helium Centre Corporation, 99.995% pure) were used as the carrier gases for the two gas chromatographs (GC) equipped with thermal conductivity detectors (TCD). N₂ (Taiyo Nippon Sanso, 99.998% pure) was used as a carrier gas for the GC equipped with a flame ionization detector (FID). H₂ (Keiyo Gas Company, 99.99% pure) along with air (from an air compressor, Hitachi) were used to make a flame in the GC-FID.

S1.2 Methods

S1.2.1 Catalysts preparation

S1.2.1.1 Deposition of Pd-Bi cocatalysts by the simultaneous photodeposition method

The Pd-Bi cocatalysts were loaded on the gallium oxide (Ga₂O₃) sample by a simultaneous photodeposition method under UV irradiation. A schematic overview is shown in Fig. S1. A detailed procedure is as follows. 1.0 g of Ga₂O₃ was dispersed in 100 mL of 10% methanol aqueous solution. This suspension was ultrasonicated for 5 min. Next, 0.2 mL of Pd standard solution and 2 mL of Bi standard solution were added to the above suspension. After ultrasonication for 5 min, the above suspension was stirred for 25 min in dark and subsequently irradiated by a 40 W low-pressure mercury lamp (ASM401N, Asumi Giken) for 1h under stirring. Then, the obtained powder was filtered, washed with deionized water 7 to 10 times, centrifuged, dried at 353 K overnight and collected. Thus prepared sample was referred to as Pd-Bi(PD)/Ga₂O₃; where the theoretical loading amount of Pd and Bi was 0.1 and 0.2 wt.%, respectively. The Pd/Bi ratio is 1.

S1.2.1.2 Deposition of single Pd and Bi cocatalysts by the photodeposition method

The single Pd and Bi cocatalyst-loaded Ga₂O₃ samples were prepared by a photodeposition method under UV irradiation. The procedure was the same as that for the simultaneous photodeposition except that only one precursor standard solution was added. Thus prepared samples were referred to as Pd(PD)/Ga₂O₃ and Bi(PD)/Ga₂O₃; where the loading amount of Pd and Bi was 0.1 and 0.2 wt.% in the first and second samples, respectively.

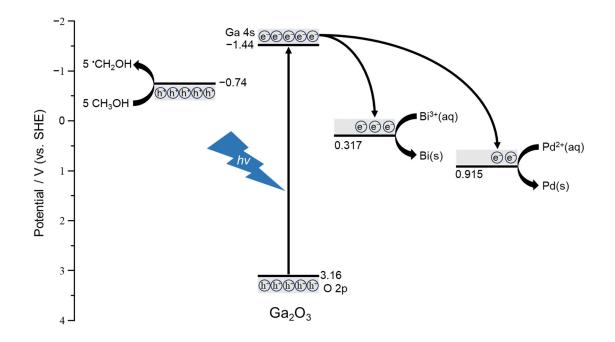


Fig. S1 Schematic overview of photodeposition method for depositing Pd and Bi on Ga₂O₃ surface using methanol as a sacrificial electron donor. The photogenerated electrons reduce the metal salt (M^{n+}) to metallic particles: $M^{n+}(aq) + ne^- \rightarrow M(s)$.

S1.2.1.3 Deposition of Pd-Bi cocatalysts by the co-impregnation method

For comparison, the Pd-Bi cocatalysts were loaded on the Ga₂O₃ by a co-impregnation method. The detailed procedure is as follows. 1.0 g of Ga₂O₃ was dispersed in 100 mL of deionized water. This suspension was ultrasonicated for 5 min. Next, 0.2 mL of Pd standard solution and 2 mL of Bi standard solution were added to the above suspension. After ultrasonication for 5 min, the above suspension was stirred in the dark for 25 min. Subsequently, the suspension was heated at 353 K under stirring to evaporate water to dryness. The obtained

powder was dried at 353 K overnight and calcined in air at 773 K for 3 h. Thus prepared sample was referred to as Pd-Bi(IMP)/Ga₂O₃; where the loading amount of Pd and Bi was 0.1 and 0.2 wt.%, respectively (Pd/Bi ratio = 1).

S1.2.1.4 Hydrogen treatment of Pd-Bi(IMP)/Ga₂O₃ at elevated temperatures

The Pd-Bi(IMP)/Ga₂O₃ sample was reduced in a flow of hydrogen (100 mL min⁻¹) at 373, 473, 673 and 973 K for 1 h. Thus prepared samples were referred to as Pd-Bi(IMP-373R)/Ga₂O₃, Pd-Bi(IMP-473R)/Ga₂O₃, Pd-Bi(IMP-673R)/Ga₂O₃ and Pd-Bi(IMP-973R)/Ga₂O₃, respectively.

S1.2.1.5 Preparation of Pd₃Bi/SiO₂ and Pd/SiO₂

Pd₃Bi/SiO₂ were synthesized by sequential impregnation method and subsequent hydrogen reduction following the procedure described in the literature [*ACS Catal.*, 2022, 10531–10545]. The detailed procedure is as follows. Aqueous ammonia solution was added to 4.2 mL of Pd standard solution until the pH became 11. Then this solution was added to 1.0 g of silica gel dropwise with continuous stirring, evaporated at 353 K and dried overnight. Then the powder was calcined at 673 K for 3 h to give the Pd(IMP)/SiO₂. Next, 10.1 mL of Bi standard solution was added to 0.5 g of Pd(IMP)/SiO₂ powder, evaporated at 353 K and dried overnight. The obtained powder was calcined at 673 K for 4 h, and reduced in hydrogen atmosphere (100 mL min⁻¹) at 473 K for 30 min followed by 823 K for 30 min. This sample is referred to as Pd₃Bi/SiO₂ for simplification. The loading amount of Pd and Bi each was 2 wt.% (Pd/Bi ratio = 2). A sample with higher loading amount (10 wt.% each) was also prepared following the same procedure.

The Pd(IMP-673R)/SiO₂ sample was prepared by the impregnation method. Aqueous ammonia solution was added to 4.2 mL of Pd standard solution until the pH became 11. Then this solution was added to 1.0 g of silica gel dropwise with continuous stirring, evaporated at 353 K, and dried overnight. Then the powder was calcined at 673 K for 3 h to give the Pd(IMP)/SiO₂. Then, the powder was reduced in a hydrogen atmosphere (100 mL min⁻¹) at 673 K for 2 h. The loading amount of Pd was 2 wt.%. A sample with higher loading amount (10 wt.%) was also prepared following the same procedure

S1.2.2 Characterization

The photocatalyst samples were characterized by several techniques. The actual loading amounts of the cocatalysts were determined by the inductively coupled plasma atomic emission spectroscopy (ICP-AES) using a Shimadzu ICPE-9820 plasma atomic emission spectrometer. The samples were dissolved in aqua regia and diluted with deionized water for the measurement. The crystal structure was determined by the powder X-ray diffraction (XRD) using a Rigaku SmartLab X-ray diffractometer with Cu Ka radiation (40 kV, 30 mA). The optical properties of the samples were measured by the diffuse reflectance ultraviolet-visible (DR UV-vis) spectroscopy using a Shimadzu UV-2600 UV-vis spectrophotometer with an ISR-2600Plus integrating sphere using barium sulfate powder as a reference. The scanning electron microscope (SEM) images were recorded on a JEOL JSM-7500F field emission scanning electron microscope. A compositional mode in retractable backscattered electron imaging (RBEI) was used to visualize the cocatalyst nanoparticles based on elemental contrast difference. The transmission electron microscope (TEM) and scanning transmission electron microscope (STEM) images with energy dispersive X-ray (EDX) mappings were recorded using a JEOL JEM-ARM200F NEOARM atomic resolution analytical electron microscope. Pd K-edge X-ray absorption fine structure (XAFS) was measured at BL01B1 and NW10A beamlines of the synchrotron radiation facilities, SPring-8 and Photon Factory (PF), respectively, in fluorescence mode using a 19-element germanium solid state detector (19 Ge SSD). The Athena program was used to analyse the obtained XAFS data. Artemis program was used for the fitting of XAFS data. MorletE program was used to make the Wavelet transform of the XAFS data. Electron spin resonance (ESR) spectra were measured using a Bruker ESR5000 spectrometer with DMPO as a spin-trapping scavenger in the aqueous suspension of photocatalyst powders.

S1.2.3 Photocatalytic reaction setup and product analysis

The reaction tests of the photocatalytic methane conversion with the water vapour were performed in a fixed bed flow reactor (volume = $5 \times 5 \times 0.025$ cm³). We spread 50 mg of the photocatalyst sample powder onto a glass plate covering an area of 25 (5×5) cm² with the help of deionized water, then it was dried at room temperature overnight. Subsequently, this photocatalyst-coated glass plate along with the quartz window plate was sandwiched between two stainless-steel plates to assemble the reactor (Fig. S2). 20 mL min⁻¹ of the pure methane was bubbled in a glass cylinder containing deionized water at room temperature and

atmosphere pressure. The resulting mixture of pure methane gas and water vapour was introduced to the reactor. Water vapour pressure (P_{H2O}) in the gas stream was measured in the range of 2.9–3.2 kPa by a dew point meter (EE3 hygrometer, Tekhne) installed in the streamline.

The photocatalyst (irradiation area 25 cm²) was irradiated by a 40 W low-pressure mercury lamp (ASM401N, Asumi Giken) held above the reactor. The intensity of the light measured by a Hamamatsu UV Power Meter C9536/H9535 at the wavelength of 254 nm was approximately 14 mW cm⁻². The reactor temperature was controlled to be 298 K by an electronic cooler (HMC-17F-2700, Hayashi Clock Industry) but increased by about 2–4 K measured by a thermocouple during the photoirradiation. The outlet gases were analysed by the gas chromatographs equipped with a thermal conductivity detector (GC-TCD, Shimadzu GC-8A) and flame ionization detector (GC-FID, Shimadzu GC-2025). The GC-TCD with the argon carrier using a packed column (Molecular Sieves 5A) was used to quantify hydrogen and oxygen. The GC-TCD with the helium carrier gas using a packed column (Shincarbon ST) was used to quantify the carbon monoxide and carbon dioxide. The GC-FID with the nitrogen carrier gas using a capillary column (PoraBOND Q) was used to quantify the hydrocarbons (ethene, ethane, and propane).

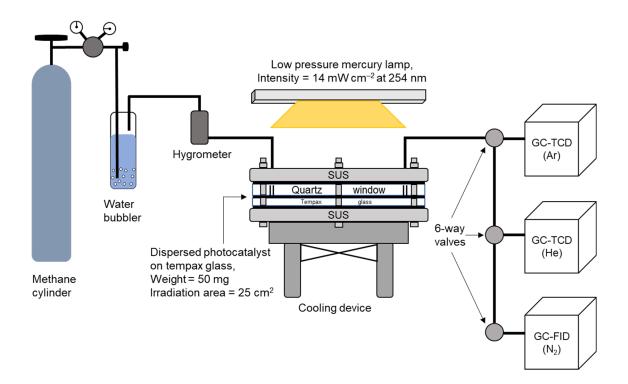


Fig. S2 Reaction set-up for the photocatalytic methane conversion with water vapour

S1.3 Calculations

S1.3.1 Selectivity

The selectivity of various products based on the carbon was calculated as shown in the following equations.

$$S_{C_{2}H_{6}}(\%) = \frac{2R_{C_{2}H_{6}}}{2R_{C_{2}H_{6}} + R_{CO_{2}} + R_{CO} + 3R_{C_{3}H_{8}} + 2R_{C_{2}H_{4}}} \times 100$$

$$S_{C_{2}H_{4}}(\%) = \frac{2R_{C_{2}H_{4}}}{2R_{C_{2}H_{6}} + R_{CO_{2}} + R_{CO} + 3R_{C_{3}H_{8}} + 2R_{C_{2}H_{4}}} \times 100$$

$$S_{CO_{2}}(\%) = \frac{R_{CO_{2}}}{2R_{C_{2}H_{6}} + R_{CO_{2}} + R_{CO} + 3R_{C_{3}H_{8}} + 2R_{C_{2}H_{4}}} \times 100$$

$$S_{CO}(\%) = \frac{2R_{CO}}{2R_{C_{2}H_{6}} + R_{CO_{2}} + R_{CO} + 3R_{C_{3}H_{8}} + 2R_{C_{2}H_{4}}} \times 100$$

where; R_x is the formation rate of product x, and S_x (%) is the selectivity of product x.

S1.3.2 Material balance

The material balance is calculated as the ratio of the hole (h^+) and electron (e^-) consumption in the photocatalytic reaction test by the following equation. The ideal h^+/e^- ratio is 1.

$$\frac{h^+}{e^-} = \frac{R_{C_2H_6} + 4R_{CO_2} + 3R_{CO} + 2R_{O_2} + 2R_{C_3H_8} + 2R_{C_2H_4}}{R_{H_2}}$$

where; R_x is the formation rate of product x.

S1.3.3 Apparent quantum efficiency (AQE)

The apparent quantum efficiency (AQE) of hydrogen and ethane formation was calculated by the following equation.

AQE (%) =
$$\frac{R_{\rm p} n_{\rm e} N_{\rm A}}{\frac{I_0 A \times 60 (\rm s \ min^{-1})}{hc/\lambda}} \times 100$$

where R_p is the formation rate of product (H₂ or C₂H₆, in mol min⁻¹), n_e is the number of electrons involved in the product formation (2 for H₂ and C₂H₆ formation), N_A is Avogadro constant (6.022 × 10²³ mol⁻¹), I_0 is irradiance (0.014 W cm⁻²), A is irradiation area (25 cm²), his Planck constant (6.626 × 10⁻³⁴ J s), c is speed of light (3.0 × 10⁸ m s⁻¹) and λ is wavelength of incident light (254 × 10⁻⁹ m).

S1.3.4 Methane conversion

The methane conversion was calculated as the ratio of moles of methane consumed to the moles of methane introduced in the feed gas according to the following equations.

 $CH_4 \text{ conversion (\%)} = \frac{\text{Moles of } CH_4 \text{ consumed}}{\text{Moles of } CH_4 \text{ fed}} \times 100$

S2. Mechanism of product formation in photocatalytic methane conversion with water vapour

In our previous study (*Energy Fuels* 2022, 36, 5393–5402), 'OH formation was observed in the Pd-loaded Ga₂O₃ photocatalyst using the ESR spin trapping technique. We proposed the mechanism for the photocatalytic ethane formation from methane in the presence of water vapour. Photogenerated hole (h⁺) oxidizes water to form 'OH, which activates methane to produce methyl radicals. The coupling of methyl radicals induces C₂H₆ formation. This 'OH-mediated reaction mechanism differs from the photocatalytic non-oxidative coupling of methane (NOCM) performed in the absence of oxidants (e.g., *Catal. Today*, 2021, **375**, 264–272 and *ACS Catal.*, 2021, **11**, 13768–13781). Photoexcited electrons induce hydrogen evolution reaction.

 $Ga_2O_3 + h \nu \rightarrow e^- + h^+$

 $2H^+ + 2e^- {\rightarrow} H_2$

 $\mathrm{H_2O} + \mathrm{h^+} \rightarrow {}^\bullet\mathrm{OH} + \mathrm{H^+}$

 ${}^{\bullet}OH + CH_4 \rightarrow {}^{\bullet}CH_3 + H_2O$

 $^{\bullet}\mathrm{CH}_{3} + ^{\bullet}\mathrm{CH}_{3} \rightarrow \mathrm{C}_{2}\mathrm{H}_{6}$

S3. Results of characterization

S3.1 Actual loading amounts of Pd and Bi

The actual loading amounts of Pd and Bi determined by ICP-AES are given in Table S1. Both Pd and Bi were almost completely loaded in all the samples.

Table S1 Loading amounts of Pd and Bi of the prepared photocatalyst samples determined by ICP-AES

Entry	Sample	Loading amount (wt.%)						
		F	Pd	Bi				
		Calculated	Measured*	Calculated	Measured*			
1	Pd(PD)/Ga ₂ O ₃	0.1	0.07	_	_			
2	Bi(PD)/Ga ₂ O ₃	_	_	0.2	0.17			
3	Pd-Bi(PD)/Ga ₂ O ₃	0.1	0.07	0.2	0.16			
4	Pd-Bi(IMP)/Ga ₂ O ₃	0.1	0.08	0.2	0.18			
5	Pd-Bi(IMP-373R)/Ga ₂ O ₃	0.1	0.08	0.2	0.21			
6	Pd-Bi(IMP-473R)/Ga ₂ O ₃	0.1	0.07	0.2	0.18			
7	Pd-Bi(IMP-673R)/Ga ₂ O ₃	0.1	0.08	0.2	0.18			
8	Pd-Bi(IMP-973R)/Ga ₂ O ₃	0.1	0.08	0.2	0.18			

*Measured by ICP-AES. Calibration curves using standard solutions of Pd and Bi of various concentrations were made.

S3.2 XRD patterns

The XRD patterns of references (β -Ga₂O₃ and α -Ga₂O₃) and Ga₂O₃ powder, Pd(PD)/Ga₂O₃, Bi(PD)/Ga₂O₃, and Pd-Bi(PD)/Ga₂O₃ samples are given in Fig. S3.

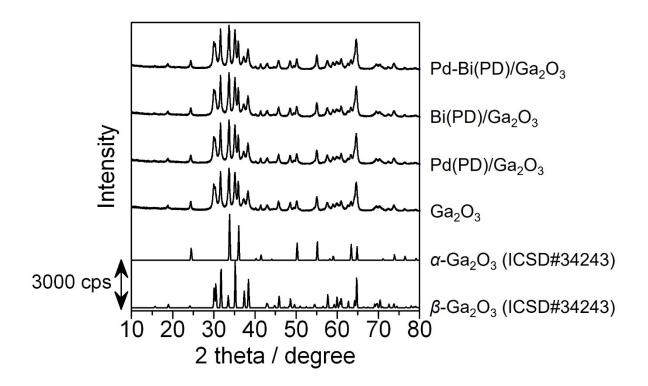


Fig. S3 XRD patterns of Ga₂O₃, Pd(PD)/Ga₂O₃, Bi(PD)/Ga₂O₃, and Pd-Bi(PD)/Ga₂O₃ samples and references.

S3.3 SEM images and particle size distributions

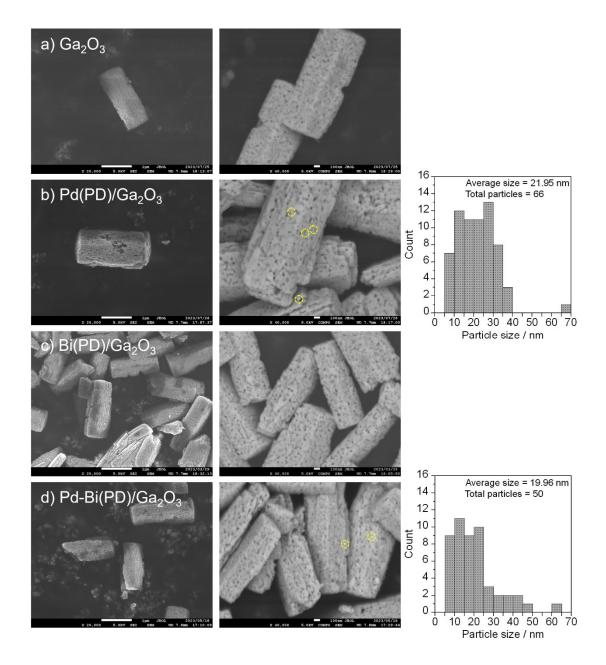


Fig. S4 Conventional SEM images (left), compositional SEM image (middle), and particle size distribution (right) for (a) Ga₂O₃, (b) Pd(PD)/Ga₂O₃, (c) Bi(PD)/Ga₂O₃, and (d) Pd-Bi(PD)/Ga₂O₃. The bright dots are encircled in the compositional images.

SEM images of Ga₂O₃, Pd(PD)/Ga₂O₃, Bi(PD)/Ga₂O₃, Pd(PD)/Ga₂O₃, and Pd-Bi(PD)/Ga₂O₃ samples in the conventional mode using secondary electron imaging (SEI) and in the compositional mode using a retractable backscattered electron imaging (RBEI) are shown in Fig. S4. Pillar-shaped Ga₂O₃ particles with a length of 1–2 µm and width of ~500 nm were observed. The morphology and particle size of Ga₂O₃ didn't change much after cocatalysts loading. The bright spots in the compositional images are assigned to the Pd cocatalyst and Pd-Bi bimetallic cocatalyst particles in the Pd(PD)/Ga₂O₃ and Pd-Bi(PD)/Ga₂O₃ samples, respectively. The particle size distribution is made as shown in Fig. S4, right side. The average particle size of the Pd cocatalyst was ~22 nm. The average particle size of Pd-Bi bimetallic nanoparticles decreased and it was ~20 nm. There were no bright spots observed in the compositional SEM images of Ga₂O₃ and Bi(PD)/Ga₂O₃ samples.

S3.4 STEM images and elemental mappings of Pd-Bi(IMP)/Ga₂O₃

The STEM image and elemental mappings of Ga, O, Pd, and Bi are shown in Fig. S5. The Pd and Bi species are dispersed on the surface of Ga₂O₃.

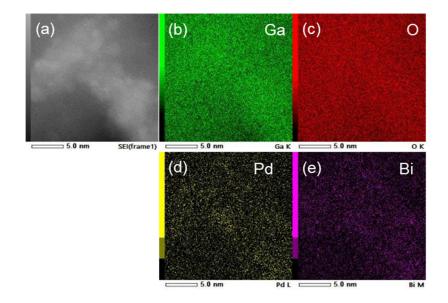


Fig. S5 (a) STEM image, and elemental mappings of (b) Ga, (c) O, (d) Pd, and (e) Bi of the Pd-Bi(IMP)/Ga₂O₃ sample.

S3.5 STEM images and elemental mappings of Pd-Bi(IMP-673R)/Ga₂O₃ sample

The STEM image and elemental mappings of the Ga, O, Pd, and Bi of the Pd-Bi(IMP-673R)/Ga₂O₃ sample are shown in Fig. S6. Pd and Bi species are dispersed on the surface of Ga₂O₃.

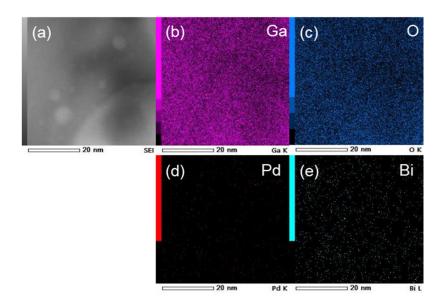


Fig. S6 (a) STEM image, and elemental mappings of (b) Ga, (c) O, (d) Pd, and (e) Bi for the Pd-Bi(IMP-673R)/Ga₂O₃ sample.

S3.6 STEM images and elemental mappings of Pd-Bi(IMP-973R)/Ga₂O₃ sample

The STEM image and elemental mappings of the Ga, O, Pd, and Bi for the Pd-Bi(IMP-973R)/Ga₂O₃ sample are shown in Fig. S7. No formation of aggregate is observed even at a high temperature of 973 K.

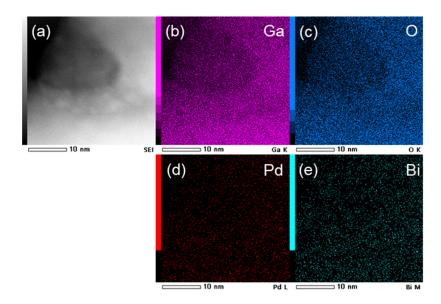


Fig. S7 (a) STEM image, and elemental mappings of (b) Ga, (c) O, (d) Pd, (e) Bi for the Pd-Bi(IMP-973R)/Ga₂O₃ sample.

S3.7 XAFS of Pd₃Bi/SiO₂ catalyst

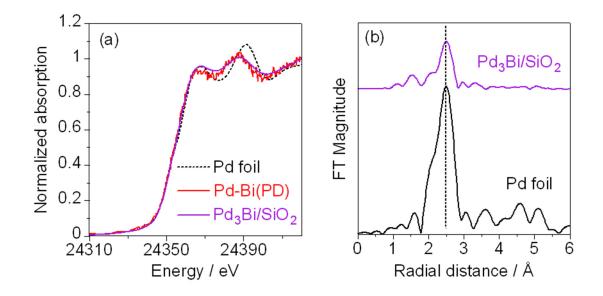


Fig. S8 a) XANES and b) FT EXAFS spectra of Pd₃Bi/SiO₂. The Pd and Bi loading amounts were 2.0 wt.% each for preparing Pd₃Bi/SiO₂.

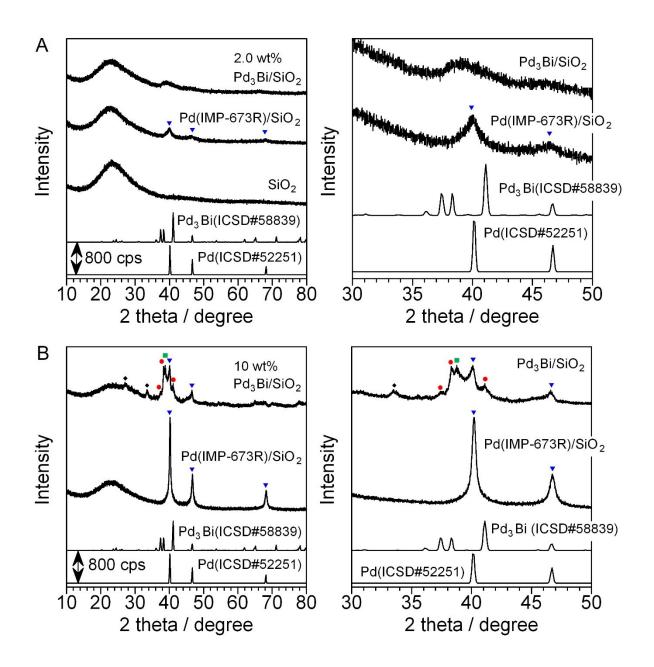


Fig. S9 XRD patterns of Pd₃Bi/SiO₂, Pd(IMP-673R)/SiO₂, SiO₂ and, references. (A) loading amount of each Pd and Bi was 2.0 wt.%, and (B) loading amount of each Pd and Bi was 10 wt.%. Symbols: circle = Pd₃Bi (ICSD#58839), triangle = Pd (ICSD#52251), diamond = α -Bi₂O₃ (ICSD#15072), square = Pd₂Si (ICSD#43209).

In the XRD pattern of the Pd₃Bi/SiO₂ sample (Fig. S9 A), distinct broad lines were observed due to the low loading amount of Pd and Bi (2 wt.% for each). We prepared the Pd₃Bi/SiO₂ with a high loading amount of Pd and Bi (10 wt.% for each) and measured the XRD patterns (Fig. S9 B). The lines corresponding to the Pd₃Bi phase can be seen clearly (red circles). In addition, the lines corresponding to the α -Bi₂O₃ phase (black diamonds) and Pd₂Bi phase (green square) were also observed.

S3.9 SEM image of Pd₃Bi/SiO₂ catalyst

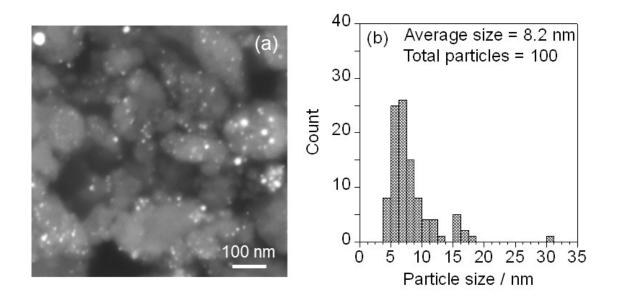


Fig. S10 a) Compositional SEM image and b) particle size distribution of Pd₃Bi/SiO₂ sample. The loading amount of Pd and Bi each was 2 wt.%.

S3.10 Properties of Pd₃Bi intermetallic compound

The crystal structure of the Pd₃Bi intermetallic compound is shown in Fig. S11.

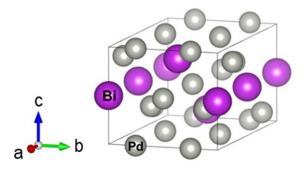


Fig. S11 Crystal structure of Pd₃Bi; Crystal system = orthorhombic, space group = Pmma, a = 9.393 Å, b = 5.752 Å, c = 4.954 Å, $\alpha = \beta = \gamma = 90^{\circ}$. Pd–Pd bond length is 2.87 Å with a coordination number of 8, while Pd–Bi bond length is 2.86 Å with a coordination number of 4.

S3.11 XAFS of Pd-Bi(IMP)/Ga₂O₃ samples

XANES spectra of Pd foil, PdO, Pd-Bi(IMP)/Ga₂O₃, Pd-Bi(IMP-673R)/Ga₂O₃, and Pd-Bi(IMP-973R)/Ga₂O₃ samples are shown in Fig. S12.

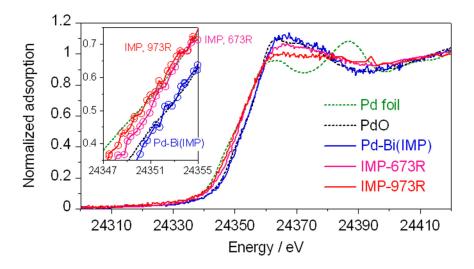


Fig. S12 Pd K-edge XANES spectra of Pd-Bi(IMP)/Ga₂O₃ and Pd-Bi(IMP-*t*R)/Ga₂O₃ samples.

S3.12 DR UV-vis spectra

The DR UV-vis spectra of the used Ga₂O₃, Bi(PD)/Ga₂O₃, Pd(PD)/Ga₂O₃, and Pd-Bi(PD)/Ga₂O₃ samples are shown in Fig. S13.

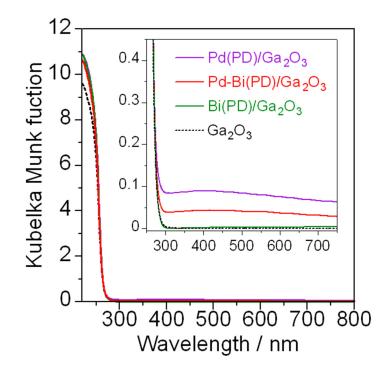


Fig. S13 DR UV-vis spectra of Ga₂O₃, Bi(PD)/Ga₂O₃, Pd(PD)/Ga₂O₃, and Pd-Bi(PD)/Ga₂O₃ samples.

S3.13 ESR spectra

In our previous study (*Energy Fuels* 2022, 36, 5393–5402), •OH formation was analysed by ESR technique with DMPO as a spin-trapping agent. We observed a direct correlation between higher •OH concentration and increased ethane selectivity. ESR spectra of the photocatalyst samples in DMPO aqueous solution were measured under UV irradiation (Fig. S14). The •OH concentration in Pd(0.1)-Bi(0.2)(PD)/Ga₂O₃ was higher than that in Pd(0.1)(PD)/Ga₂O₃. Thus, in the present case also, the enhanced ethane selectivity is related to the increase in the •OH concentration over Pd-Bi(PD)/Ga₂O₃ photocatalyst.

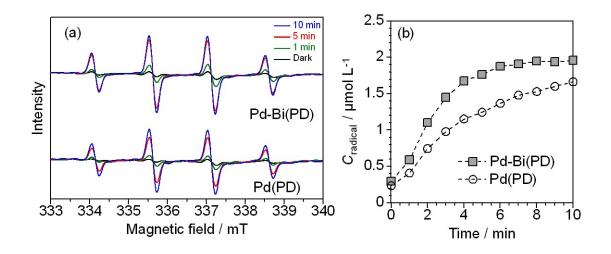


Fig. S14 (a) in-situ ESR spectra in the presence of DMPO and (b) time course of •DMPO-OH generation for Pd(PD)/Ga₂O₃, and Pd-Bi(PD)/Ga₂O₃ samples under UV irradiation.

S4. Results of reaction tests

S4.1 Results of reaction tests

The production rates and the ratio of consumed electrons and holes in the reaction are given in Table S2. The h^+/e^- value was slightly less than 1. In the case of Ga₂O₃, this was due to the error in the estimation of the low amount of products while in other cases, a small amount of carbon might be formed (*J. Catal.*, 2021, **397**, 192–200).

Table S2 Results of reaction test of photocatalytic methane conversion with water vapour over various samples

Entry	Photocatalyst	Production rate ^a / µmol min ⁻¹					h ⁺ /e	
	-	H ₂	C ₂ H ₆	C ₂ H ₄	C ₃ H ₈	CO ₂	СО	_
1	Ga ₂ O ₃	0.13	0.002	0	0	0.02	0.010	0.80
2	Pd(PD)/Ga ₂ O ₃	1.94	0.41	0.010	0.005	0.35	0.011	0.96
3	Pd-Bi(PD)/Ga ₂ O ₃	1.00	0.44	0.007	0.009	0.12	0.009	0.94
4	Bi(PD)/Ga ₂ O ₃	0.27	0.003	0	0.003	0.05	0.015	0.89
5	Pd-Bi(IMP)/Ga ₂ O ₃	0.44	0.19	0.005	0.002	0.04	0.005	0.87
6	Pd-Bi(IMP-373R)/Ga ₂ O ₃	0.54	0.25	0.005	0.002	0.05	0.003	0.89
7	Pd-Bi(IMP-473R)/Ga ₂ O ₃	0.58	0.27	0.005	0.004	0.05	0.004	0.90
8	Pd-Bi(IMP-673R)/Ga ₂ O ₃	0.52	0.18	0.009	0.003	0.06	0.004	0.90
9	Pd-Bi(IMP-973R)/Ga ₂ O ₃	0.50	0.18	0.007	0.004	0.06	0.004	0.91

^a The production rates were measured after 3 h photoirradiation.

The apparent quantum efficiencies (AQEs) for H₂ and C₂H₆ formation in the photocatalytic methane conversion with water vapour for various samples are given in Table S3.

Entry	Photocatalyst	AQE (H ₂)	AQE (C ₂ H ₆)
		(%)	(%)
1	Ga ₂ O ₃	0.58	0.01
2	Pd(PD)/Ga ₂ O ₃	8.70	1.84
3	Pd-Bi(PD)/Ga ₂ O ₃	4.49	1.97
4	Bi(PD)/Ga ₂ O ₃	1.21	0.01
5	Pd-Bi(IMP)/Ga ₂ O ₃	1.97	0.85
6	Pd-Bi(IMP-373R)/Ga ₂ O ₃	2.42	1.12
7	Pd-Bi(IMP-473R)/Ga ₂ O ₃	2.60	1.21
8	Pd-Bi(IMP-673R)/Ga ₂ O ₃	2.33	0.81
9	Pd-Bi(IMP-973R)/Ga ₂ O ₃	2.24	0.81

Table S3 Apparent quantum efficiency (AQE) for H₂ and C₂H₆ formation

The percentage methane conversion, yield of ethane and selectivity of various products based on carbon basis are given in Table S4.

Entry	Photocatalyst	CH ₄ conversion	C ₂ H ₆ yield	$S_{\rm C2H6}$	$S_{\rm CO2}$
		(%)	/ $\mu mol \ g_{cat}^{-1} \ h^{-1}$	(%) ^a	(%) ^a
1	Ga ₂ O ₃	0.004	2.4	12	60
2	Pd(PD)/Ga ₂ O ₃	0.15	492	68	28
3	Pd-Bi(PD)/Ga ₂ O ₃	0.13	528	84	11
4	Bi(PD)/Ga ₂ O ₃	0.010	3.6	7	62
5	Pd-Bi(IMP)/Ga ₂ O ₃	0.054	228	86	9
6	Pd-Bi(IMP, 373R)/Ga ₂ O ₃	0.070	300	87	9
7	Pd-Bi(IMP, 473R)/Ga ₂ O ₃	0.075	324	87	8
8	Pd-Bi(IMP, 673R)/Ga ₂ O ₃	0.055	216	80	14
9	Pd-Bi(IMP, 973R)/Ga ₂ O ₃	0.055	216	80	14

Table S4 Percentage methane conversion, yield of ethane and the product selectivity

^{*a*} Calculated from the values in Table S2.

S4.2 Time courses of product formation

The time courses of H₂, C₂H₆, CO₂ and CO formation over various samples are shown in Fig. S15.

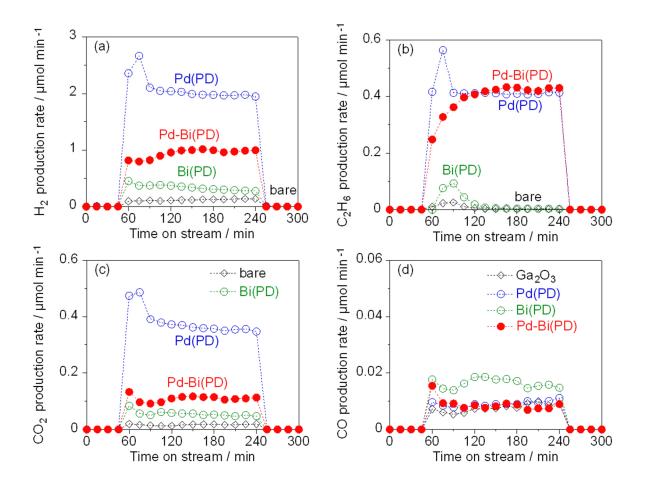


Fig. S15 Time courses of (a)H₂, (b) C₂H₆, (c) CO₂ and (d) CO formation over various samples.

S4.3 Control Experiments

The results of control experiment tests over the Pd-Bi(PD)/Ga₂O₃ samples are shown in Table S5. In the absence of CH₄, only a small amount of H₂ was produced and no other products were detected. Comparison of entry 1 and 2 shows that the products H₂, C₂H₆, C₂H₄, CO₂ and CO are derived from CH₄. In the flow of only CH₄ without water vapor (entry 3), the production rates decreased due to the absence of •OH. In the absence of any oxidants, non-oxidative coupling of methane (NOCM, 2CH₄ \rightarrow C₂H₆ + H₂) proceeds and the production rates are generally low. However, in the present case (entry 3), small amounts of carbon oxides were also observed. This was due to the presence of adsorbed H₂O in the gas line which is very difficult to remove completely. A low value of h⁺/e⁻ would result from the error in the estimation of the low amount of products similar to the case of Ga₂O₃.

Entry	Reactant		Production rate ^{<i>a</i>} / μ mol min ⁻¹						
		H ₂	C ₂ H ₆	C ₂ H ₄	C ₃ H ₈	CO ₂	СО	_	
1	$Ar + H_2O$	0.02	0	0	0	0	_b	0	
2	$\mathrm{CH}_4 + \mathrm{H}_2\mathrm{O}$	1.00	0.44	0.007	0.009	0.12	0.009	0.94	
3	CH4	0.039	0.011	0	0.0005	0.002	0.001	0.67	

Table S5 Results of control experiments with Pd-Bi(PD)/Ga₂O₃ photocatalyst

^{*a*} The production rates were measured after 3 h photoirradiation. ^{*b*} The peaks of Ar and CO were overlapped in the control experiment 1 and so CO production rate couldn't be analysed.